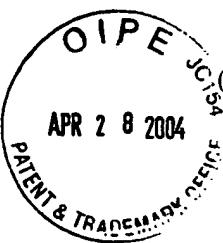


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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
MASAFUMI SANO ET AL.)
Application No.: 10/046,903)
Filed: January 17, 2002)
For: METHOD OF PRODUCING)
ZINC OXIDE THIN FILM,)
METHOD OF PRODUCING)
PHOTOVOLTAIC DEVICE)
AND METHOD OF PRODUCING)
SEMICONDUCTOR DEVICE : April 27, 2004
: Examiner: Edna Wong
: Group Art Unit: 1753

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

a) Introductory Comments

In response to the Office Action dated February 2, 2004, kindly amend the
subject application as follows.